

<sup>1</sup>W. P. Dumke and R. R. Haering, Phys. Rev. 126, 1974 (1962).

<sup>2</sup>J. J. Hopfield, Phys. Rev. Letters 8, 311 (1962).

<sup>3</sup>Shulamith G. Eckstein (to be published).

<sup>4</sup>A. R. Hutson, J. H. McFee, and D. L. White, Phys.

Rev. Letters 7, 237 (1961).

<sup>5</sup>Y. Eckstein, A. W. Lawson, and Darrell H. Reneker, J. Appl. Phys. 31, 1534 (1960).

<sup>6</sup>Leo Esaki, Phys. Rev. Letters 8, 4 (1962).

<sup>7</sup>Leo Esaki (private communication).

ELECTRON-HOLE AND ELECTRON-IMPURITY BAND TUNNELING  
IN GaAs LUMINESCENT JUNCTIONS

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The possibility of photon-assisted tunneling in *pn* junctions has been considered by Aigrain,<sup>1</sup> Sommers,<sup>2</sup> and more recently by Pankove.<sup>3</sup>

We wish to report a group of measurements performed on electroluminescent GaAs diodes and to propose two tunneling mechanisms which are in quantitative agreement with these data.

Figure 1 includes a plot of the integrated light intensity *I* at 77°K vs the applied voltage *V<sub>x</sub>*. The diode was prepared by diffusing Zn from a surface concentration of *p* = 5 × 10<sup>18</sup> cm<sup>-3</sup> into a GaAs crystal doped with *n* = 2.5 × 10<sup>18</sup> cm<sup>-3</sup> Te atoms. In region A, 1.23 V < *V<sub>x</sub>* < 1.37 V, the intensity is given by *I* = *I*<sub>0</sub> exp[*S<sub>A</sub>* *V<sub>x</sub>*], where *S<sub>A</sub>* = 42 V<sup>-1</sup>. In region B, *V<sub>x</sub>* > 1.37 V, the slope changes to *S<sub>B</sub>* = 100 V<sup>-1</sup>. The values of *S<sub>A</sub>* and *S<sub>B</sub>* remain constant down to 4.2°K.

The main support for a tunneling model comes from the observation of the temperature independence of *S<sub>A</sub>* and *S<sub>B</sub>*. If the current were due to diffusion, *S* should be proportional to *T*<sup>-1</sup>. The increase in the magnitude of the slope which occurs in moving from region A to B suggests the existence of two distinct tunneling mechanisms.

The model proposed to explain the diode behavior in region A is shown in Fig. 2. An electron on the *n* side of the junction and a hole from the *p* side tunnel into the junction region and recombine emitting a photon of energy *hν*. The matrix element describing this transition is

$$\mathcal{M}_{cv} = \int \psi_c(\mathbf{r}) \exp[i\vec{k}_c(\mathbf{r}) \cdot \vec{r}] P \psi_v^*(\mathbf{r}) \times \exp[-i\vec{k}_v(\mathbf{r}) \cdot \vec{r}] d\mathbf{r}, \quad (1)$$

where  $\psi_c$  and  $\psi_v$  are the wave functions for the conduction band and the valence band, respectively, at *k* = 0. *P* is the momentum operator.

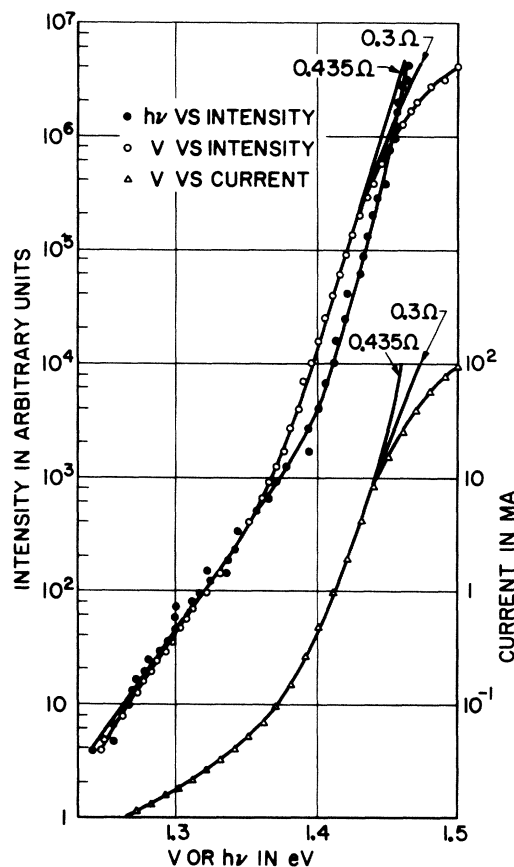


FIG. 1. A plot of the integrated radiation intensity vs the total applied voltage and the photon energy at maximum light output. To correct for series resistance, the voltage drops across *R* = 0.435 Ω and *R* = 0.3 Ω are subtracted. These corrections become important at *V<sub>x</sub>* > 1.43 V. The lowest curve is that of the diode current. The quantum efficiency approaches a constant value (~1) at *V<sub>x</sub>* > 1.38 V. The temperature is 77°K.

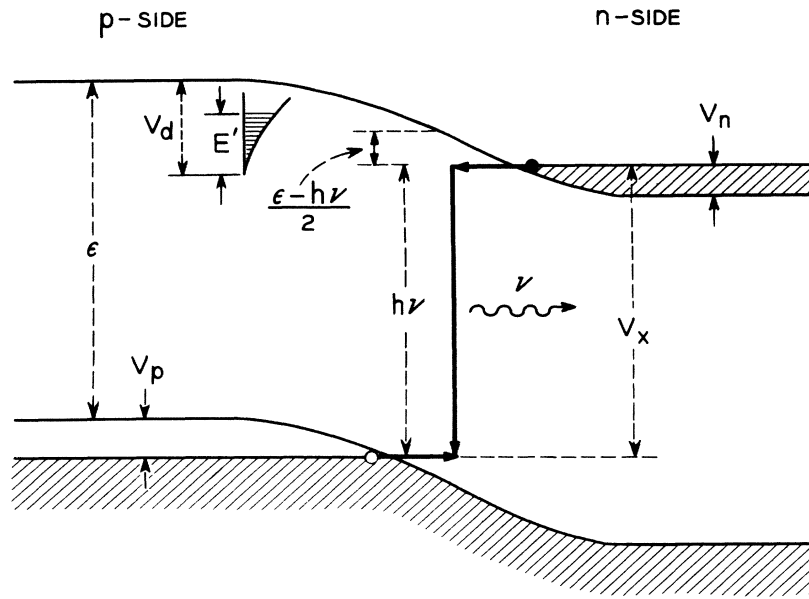


FIG. 2. A model for the electron-hole photon-assisted tunneling and the impurity-band tunneling in a GaAs  $pn$  junction. The second tunneling mechanism becomes operative as the applied voltage  $V_x$  is increased, above its value in this figure, so that  $V_n$  lies opposite the impurity band.

The transition is thus described by a single matrix element and does not involve virtual states.<sup>3</sup> The main contribution to (1) is from the "tunneling" region where the components of  $\vec{k}_c(r)$  and  $\vec{k}_v(r)$  in the direction normal to the junction plane are imaginary.

To test our model, we calculate the simultaneous tunneling probability to midjunction<sup>4</sup> of a hole near the Fermi level on the  $p$  side and of an electron on the  $n$  side as shown in Fig. 2. The tunneling probability for each one of these events is given by Keldysh<sup>5</sup> as

$$P_x = \exp[-\alpha \epsilon_x^{3/2}/E], \quad (2)$$

where  $\alpha = \pi(m)^{1/2}/2eh$ ,  $m$  is the tunneling mass,  $E$  is the electric field in the junction, and  $\epsilon_x$  is the energy barrier through which the electron and hole tunnel. From Fig. 2 we have

$$\epsilon_x = \frac{1}{2}(\epsilon - h\nu) = \frac{1}{2}e(V_i - V_x), \quad (3)$$

for  $V_n + V_p \ll \epsilon/e - V_x$ .  $\epsilon$  is the energy gap and  $eV_i$  is the built-in potential  $eV_i = \epsilon + e(V_p + V_n)$ .

A plot of the measured diode capacitance vs voltage showed that the impurity profile is of the linear-gradient type, and the junction width  $W$  is given by

$$W = W_1(V_i - V_x)^{1/3}, \quad (4)$$

with  $W_1 = 1300 \text{ \AA} \cdot \text{V}^{-1/3}$ . The electric field  $E$  is

taken as the maximum field

$$E_m = 1.5(V_i - V_x)/W. \quad (5)$$

Combining (2), (3), (4), and (5), we get

$$I \propto P_x^2 = \exp[-\alpha W_1 e^{3/2}/1.5\sqrt{2}(V_i - V_x)^{5/6}], \quad (6)$$

where we assume that most of the emitted radiation is due to electron-hole midjunction tunneling.

A plot of  $\log I$  vs  $V_x$  should thus possess a slope  $S$  given by<sup>6</sup>

$$S = (5/6)(\alpha W_1 e^{3/2}/1.5\sqrt{2})(V_i - V_x)^{-1/6}. \quad (7)$$

The factor  $(V_i - V_x)^{-1/6}$  varies between 0.76 and 0.85 over the range of  $V_x$  plotted in Fig. 1. This small deviation from a constant slope behavior could not be resolved in a logarithmic plot such as that of Fig. 1 and none, indeed, was observed.

To calculate  $S$  we use  $W_1 = 1300 \text{ \AA} \cdot \text{V}^{-1/3}$ ,  $m^{-1} = m_h^{-1} + m_e^{-1} = (0.04 m_0)^{-1}$ , and replace the function  $(V_i - V_x)^{-1/6}$  by its average value over the range  $1.25 < V_x < 1.37$  which is  $\sim 0.8$ . The result is

$$S_{\text{calc}} = 47 \text{ V}^{-1},$$

which is to be compared with the measured value  $S = 42 \text{ V}^{-1}$ .

The following added observations are consist-

ent with the tunneling model proposed above: (a) The emitted frequency at peak output is, as shown in Fig. 1, equal to  $eV_x/h$ , (b) the measured slope  $S$  in diodes with a different doping profile remains proportional to  $W_1$ , and (c) spectra in region  $A$  show multiple peaks resulting from the interference of primary beams from the recombination region and secondary beams reflected from the surface of the diode. This interference implies a narrow recombination region. We deduce an upper limit of about 500 Å. This region, as has been suggested by Kane,<sup>8</sup> would correspond to the part of the junction where the overlap of  $\psi_v(r)$  and  $\psi_e(r)$  is a maximum. No interference peaks are observed in region  $B$ .

The different value of  $S_B$  for  $V_x > 1.37$  can be explained if we assume that the radiation is due to electrons tunneling into an impurity band as shown in Fig. 2 (a distance  $V_d$  below the conduction band edge). The existence of such a band with a density of states

$$\rho(E') = \text{const} \times \exp[aE'] \quad (8)$$

has been suggested by Nelson et al.<sup>8</sup> If the current cycle is completed by a radiative recombination with a characteristic lifetime  $\tau$  which is independent of  $E'$ , we can write

$$g \propto \exp[aE']. \quad (9)$$

Since only electrons near the top of the Fermi level find themselves opposite empty states in the band, we have from Fig. 2,

$$E' = e(V_d - V_i + V_n + V_x),$$

which when substituted in (9) yields

$$S_B = ea. \quad (10)$$

As an independent check we plotted  $\log g$  vs  $h\nu$ . The band-filling model requires that at peak output  $h\nu = eV_x + eV_0$ , where  $V_0$  is some constant voltage. As a consequence, a plot of  $\log g$  vs  $h\nu$  should possess the same slope as  $\log g$  vs  $eV_x$ . This, as shown in Fig. 1, is the case. The two values of  $S_B$  thus measured are both  $100 \text{ V}^{-1}$ .

If we assume that in region  $B$  the recombination takes place from the impurity band to the valence band, we should have, at  $T = 0^\circ\text{K}$ ,  $eV_x$

$= h\nu + eV_0$ , where  $V_0 \sim S^{-1}$ . This is the case at  $4.2^\circ$  and  $20^\circ\text{K}$  where  $S^{-1}$  is 10 mV while the measured  $V_0$  is 15 mV. At  $77^\circ\text{K}$  we find (see Fig. 1)  $V_0 = -14$  mV. Although a decrease in  $V_0$  with increasing temperature is expected, we could not account quantitatively for the observed decrease.

By comparing the radiation intensity and the total current data of Fig. 1, it becomes clear that the recombination quantum efficiency in region  $A$  is very small. As a matter of fact, a relationship  $g \propto I^{3.3}$  is found to hold over a 10:1 range of current. In region  $B$  the radiation intensity becomes approximately proportional to the total current  $I$  which indicates a constant quantum efficiency.

The mechanism of excess current flow in region  $A$  must involve tunneling since its characteristics are, too, temperature independent. An investigation into its nature is now in progress.

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<sup>1</sup>A. G. Chynoweth (private communication).

<sup>2</sup>H. S. Sommers, Jr., Phys. Rev. **124**, 1101 (1961).

<sup>3</sup>J. I. Pankove, Phys. Rev. Letters **9**, 283 (1962).

<sup>4</sup>E. O. Kane has shown (private communication) that the integrand in (1), for the case of a symmetric function with  $m_e = m_h$ , is a maximum at midjunction so that most of the recombination is expected to take place in this region.

<sup>5</sup>L. V. Keldysh, Zh. Eksperim. i Teor. Fiz. **34**, 962 (1958) [translation: Soviet Phys. - JETP **7**, 665 (1958)].

<sup>6</sup>A similar procedure was used by A. G. Chynoweth, W. L. Feldman, and R. A. Logan [Phys. Rev. **121**, 684 (1961)] in investigating the excess current in silicon Esaki junctions.

<sup>7</sup>M. Gershenson, D. F. Nelson, A. Ashkin, L. A. D'Asaro, and J. C. Sarace, Bull. Am. Phys. Soc. **8**, 202 (1963).

<sup>8</sup>E. O. Kane (private communication).